

HIGH-EFFICIENCY SOLAR CELLS

N87-16417

**SiN<sub>x</sub> PASSIVATION OF SILICON SURFACES**

UNIVERSITY OF WASHINGTON

L. C. Olsen

**Objectives and Approach****OBJECTIVES**

- RELATE SURFACE DENSITY TO SUBSTRATE DOPANT CONCENTRATION
- SURFACE CHARACTERIZATION OF HIGH EFFICIENCY n +/p and p +/n SILICON CELLS
- IDENTIFY DOMINANT CURRENT LOSS MECHANISMS IN HIGH EFFICIENCY CELLS

**APPROACH**

- MEASURE DENSITY OF STATES ON HOMOGENEOUSLY DOPED SUBSTRATES WITH HIGH FREQUENCY C-V AND Al/SiN<sub>x</sub>/Si STRUCTURES
- INVESTIGATE DENSITY OF STATES AND PHOTORESPONSE OF HIGH EFFICIENCY N +/P and P +/N CELLS.
- CONDUCT I-V-T STUDIES TO IDENTIFY CURRENT LOSS MECHANISMS IN HIGH EFFICIENCY CELLS

**Presentation Outline****1. SURFACE PASSIVATION**

- SiN<sub>x</sub> DEPOSITION
- HOMOGENEOUSLY DOPED SUBSTRATES
- PHOTORESPONSE OF N +/P AND P +/N CELLS

**2. SOLAR CELL STUDIES**

- MINP CELL WITH TEXTURED SURFACE

**3. CURRENT LOSS MECHANISMS**

- LIGHT INDUCED CURRENT LOSS MECHANISM
- Mg MIS CONTACTS
- NEUTRON ACTIVATION

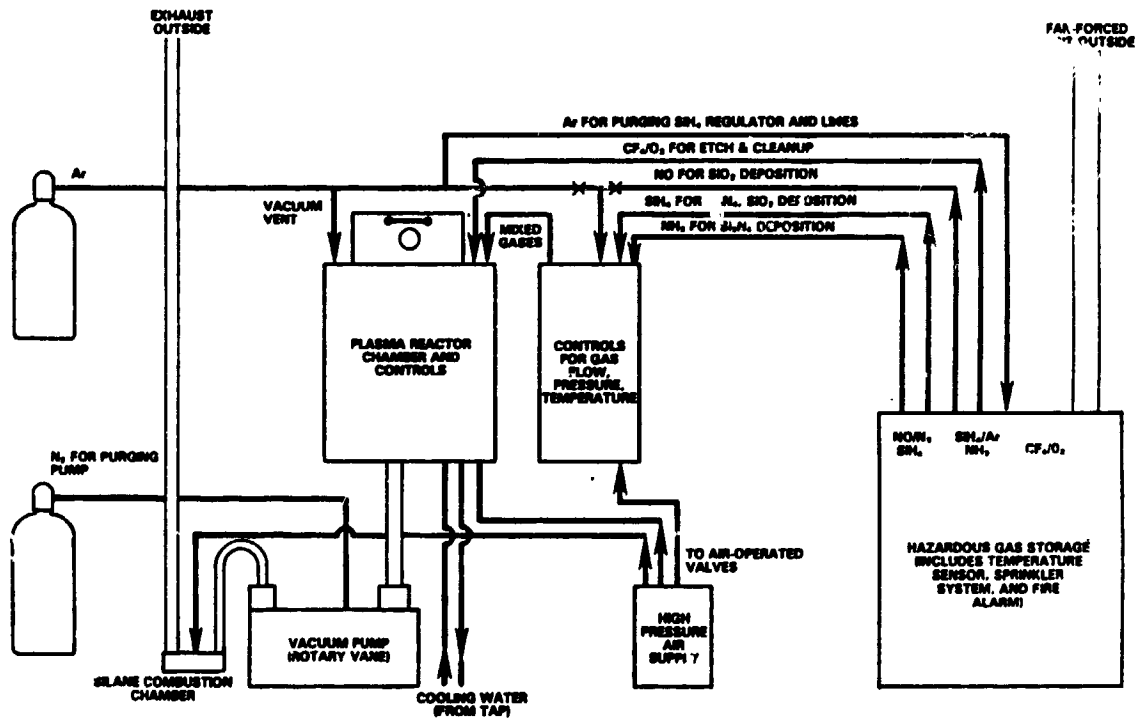
**4. FUTURE WORK**

- PASSIVATION OF P +/N CELLS
- FINAL REPORT CONCERNING SiN<sub>x</sub> PASSIVATION OF SILICON

PRECEDING PAGE BLANK NOT FILMED

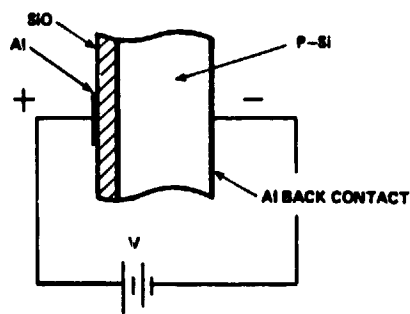
# HIGH-EFFICIENCY SOLAR CELLS

## Schematic of PECVD System



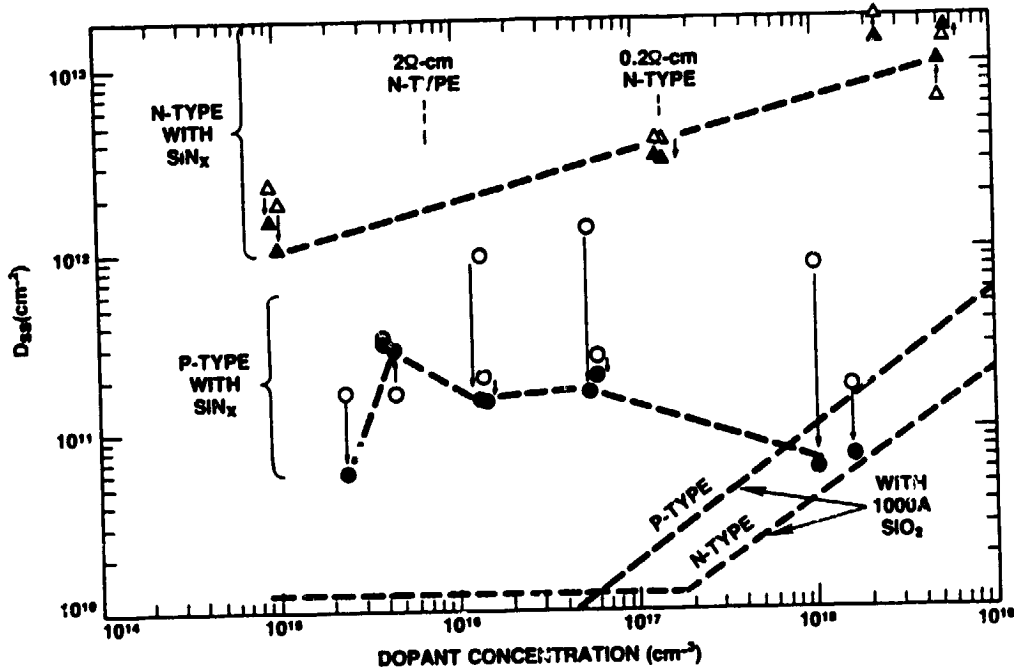
## Fabrication of Al/SiN<sub>x</sub>/Si MIS Structures

- CLEAN SILICON SUBSTRATES WITH RCA PROCESS
- SUBJECT SUBSTRATE TO NITRIDING STEP (LOW RF POWER WITH NH<sub>3</sub> @ 70 SCCM)
- DEPOSIT ≈ 100 Å SiN<sub>x</sub> WITH SUBSTRATE AT 270 °C AND RF POWER @ 212 W/cm<sup>2</sup>
- DEPOSIT ≈ 600 Å SiN<sub>x</sub> WITH POWER @ 1225 W/cm<sup>2</sup>
- DEPOSIT ALUMINUM



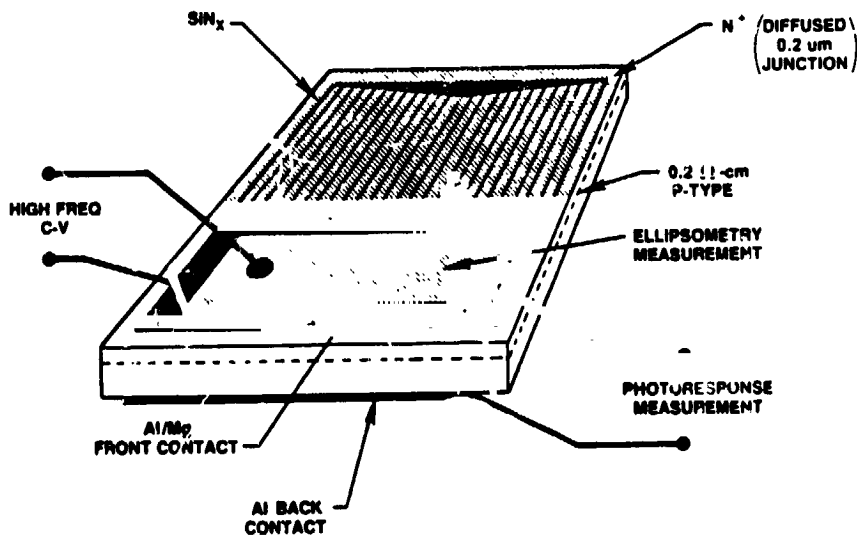
# HIGH-EFFICIENCY SOLAR CELLS

## Midgap Interface State Density Versus Dopant Concentration



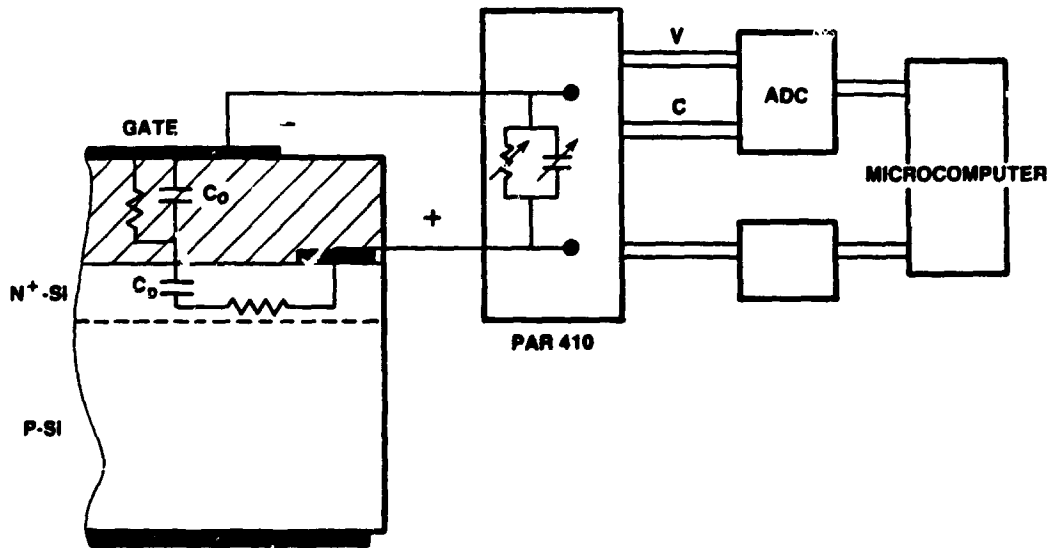
△, ○ AS DEPOSITED  
 △, ● AFTER HEAT TREATMENT @ 450°C

## Device Structure for Surface Recombination Study

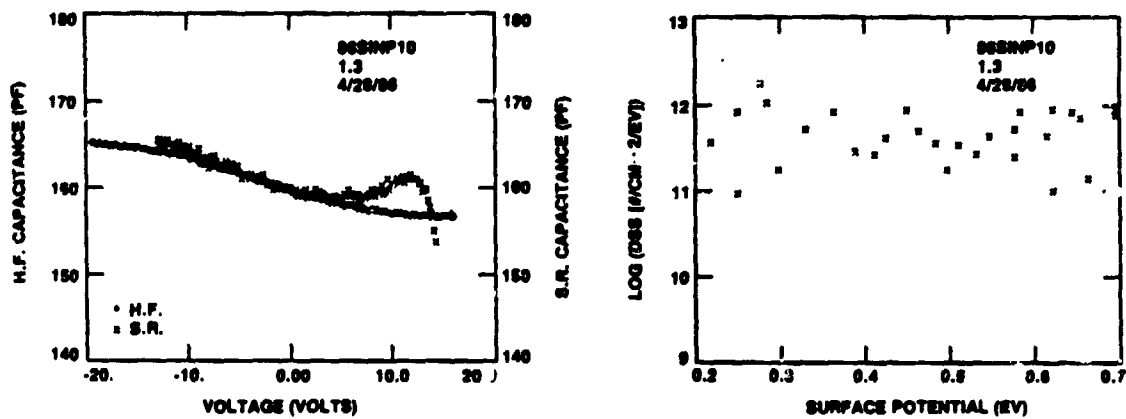


# HIGH-EFFICIENCY SOLAR CELLS

## C-V Measurement of Interface Density at N<sup>+</sup> Surface of N<sup>+</sup>/P Cell

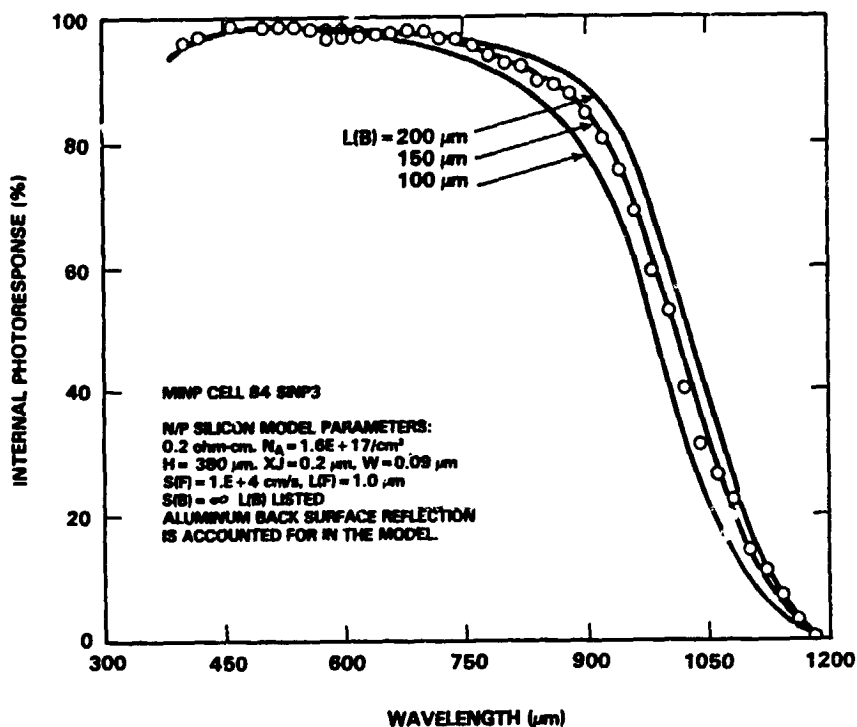


## Density of States of Surface of P<sup>+</sup>/N Cell

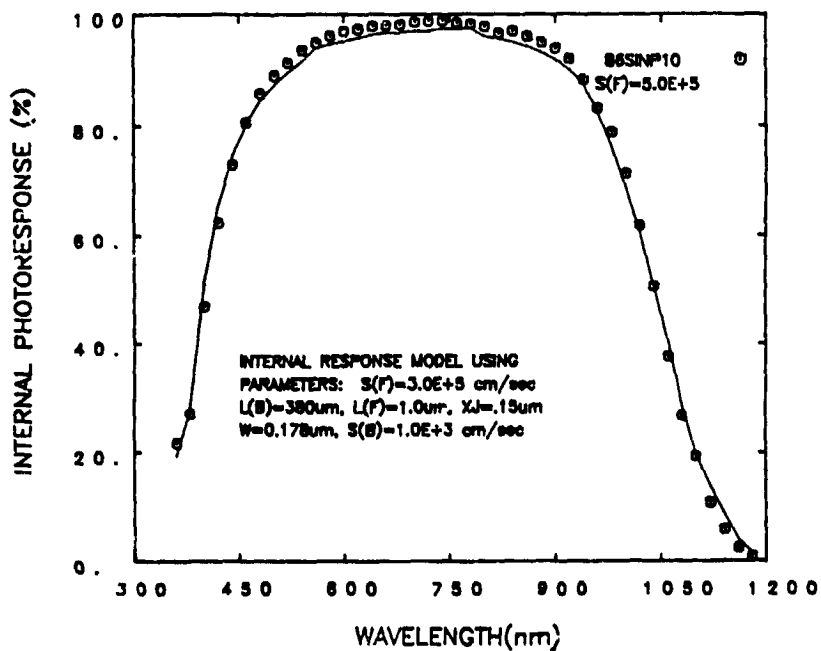


# HIGH-EFFICIENCY SOLAR CELLS

## Internal Photoresponse for 0.2 ohm-cm iNIP Cell

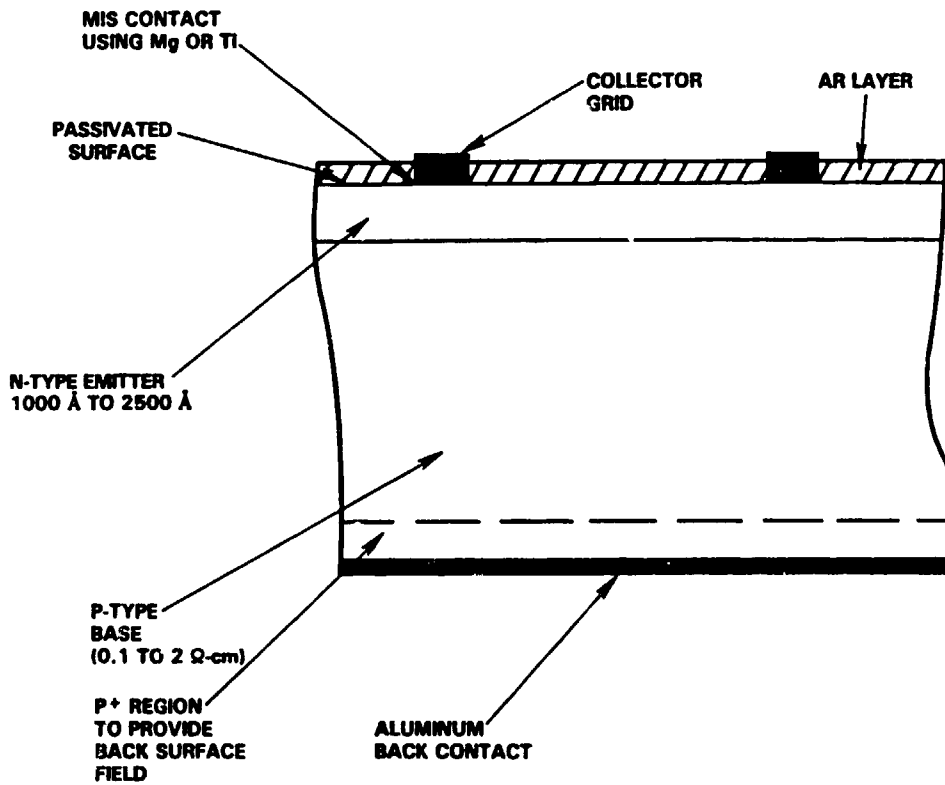


## Internal Photoresponse for 0.2 ohm-cm P<sup>+</sup>/N Cell

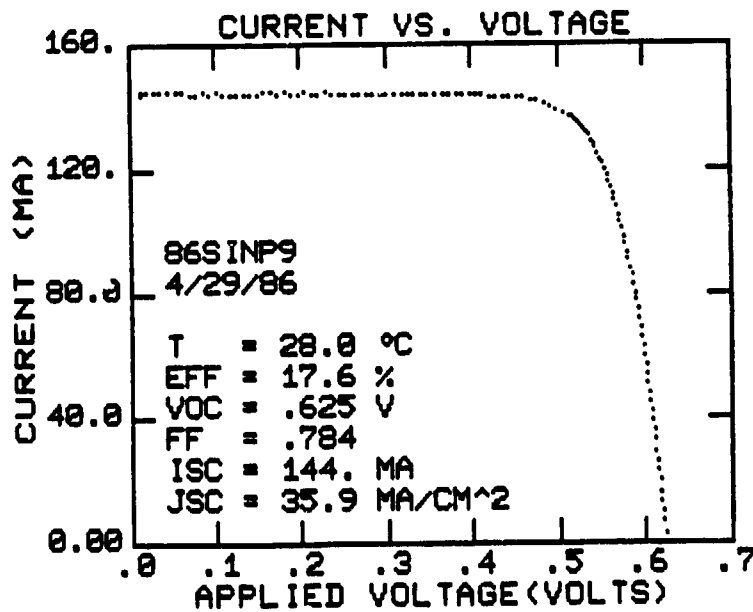


# HIGH-EFFICIENCY SOLAR CELLS

## MINP Cell Concept

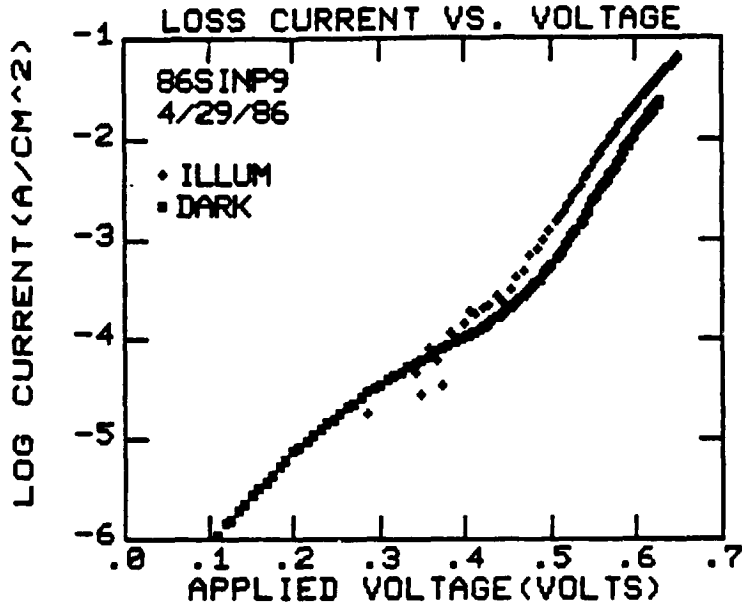


## AM1 Characteristics of Textured MINP Cell



# HIGH-EFFICIENCY SOLAR CELLS

## Loss Current Versus Voltage for Illuminated and Dark Characteristics of Textured MINP Cell



## Neutron Activation Measurement of Impurity Concentration

SAMPLE	Au (ppms)	Co (ppms)	Sc (ppms)	Hg (ppms)	Fe (ppms)	COMMENT
AS RECEIVED	< 3E-6	< 2E-3	.	< 3E-4	< 2.5	AS RECEIVED FROM WACKER
AFTER DIFFUSION	< 1.0E-5	3.8 E-3	.	< 3E-4	< 2.0	AFTER P-DIFFUSION BY ASEC
84 SINP4	1.2 E-4	11 E-3	4.4 E-3	< 3E-4	< 2.5	DARK: $J_0 = 1.0 \text{ E-13 A/cm}^2$ $n = 1.00$ ILLUM: $J_0 = 2\text{E-11 A/cm}^2$ $N = 1.16$
85 SINP20	5.7 E-5	8.1 E-3	.	30 E-4	< 2.5	L=35 $\mu$ m CONTAMINATE DH <sub>2</sub> O
85SINP40	9.0 E-5	7.5 E-3	.	< 3E-4	< 2.5	L=220 $\mu$ m GOOD TRANSLATION

# HIGH-EFFICIENCY SOLAR CELLS

## Mg MIS Contact Study

METAL COVERAGE	HIGH VOLTAGE MECHANISM	
	$J_0$ ( $A/cm^2$ )	$n$
62%	$1.5 \times 10^{-12}$	1.03
3.6%	$1.2 \times 10^{-12}$	1.01
1.5%	$1.6 \times 10^{-12}$	1.03

BASE RESISTIVITY = 0.2 Ohm-cm  
JUNCTION DEPTH = 0.2  $\mu$ m

